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PATENT 4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Inventors: Kenneth C. Johnson, et al.

Application No.: 09/938,415

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For: OPTIMIZED APERTURE SHAPE FOR  
OPTICAL CD/PROFILE METROLOGY

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Examiner: Andrew T. Sever

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(37 CFR 1.8(a))**

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